



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

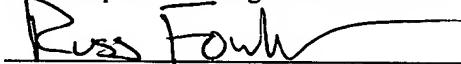
In re Application of: Tilke et al.) Group Art Unit: 2811
)
 Attorney Docket No. 1890-0061) Confirmation No.: 7063
)
 Application No.: 10/780,276) Examiner: Thien F. Tran
)
 Filed: February 17, 2004)
)
 For: Semiconductor Structure With)
 Increased Breakdown Voltage and)
 Method for Producing the)
 Semiconductor Structure)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

"I hereby certify that this correspondence is being deposited
with the United States Postal Service in an envelope
addressed to: Mail Stop Amendment, Commissioner of Patents,
P.O. Box 1450, Alexandria, VA 22313-1450
on July 5, 2005

(Date of Deposit)
Russell E. Fowler

Name of person mailing Document or Fee


Signature

July 5, 2005

Date of Signature

AMENDMENT & RESPONSE

Sir:

In response to the Office action of May 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.